

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of:

Richard Fastow : Group Art Unit: Not yet assigned

Serial No.: Not yet assigned : Examiner: Not yet assigned

Filed: Herewith :

Title: SEMICONDUCTOR COMPONENT AND METHOD OF MANUFACTURE

INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

Sir:

Attached hereto is a completed Form PTO-1449 listing patents, publications, or other information which the applicant believes may be material to the examination of this application, with copies of each such item enclosed herewith. It is requested that the cited patents be made of record in the examination of this application. This information disclosure statement is being filed prior to the first Office Action and no certification or fee is required. The commissioner is authorized to charge any fee deficiency required by this paper or credit any overpayment to Deposit Account No. 50-2173. A duplicate of this communication is enclosed.

Respectfully submitted,

Dated: 8 March 2004

By Rennie William Dover
Rennie William Dover, Reg. No. 36,503
1850 N. Central Avenue, Ste. 2400
Phoenix, AZ 85004
Telephone: (602) 322-4000

FORM PTO-1449		U.S. DEPARTMENT OF COMMERCE		ATTY. DOCKET NO. H1807		SERIAL NO Not yet assigned
		PATENT AND TRADEMARK OFFICE		APPLICANT Richard Fastow		
		INFORMATION DISCLOSURE STATEMENT BY APPLICANT		FILING DATE Herewith		GROUP Not yet assigned
		(Use several sheets if necessary)				

U.S. PATENT DOCUMENTS

EXAMINER INITIAL	DOCUMENT NUMBER	DATE	NAME	CLASS	SUBCLASS	FILING DATE IF APPROPRIATE
	6,449,188	09/10/02	Fastow			
	6,525,368	02/25/03	Fastow			
	6,552,435	04/22/03	Noble			
	6,573,137	06/03/03	Divakaruni, et al.			
	6,583,479	06/24/03	Fastow, et al.			

FOREIGN PATENT DOCUMENTS

	DOCUMENT NUMBER	DATE	COUNTRY	CLASS	SUBCLASS	TRANSLATION	
						YES	NO

OTHER DOCUMENTS (Including Author, Title, Date Pertinent Pages, Etc.)

EXAMINER	DATE CONSIDERED
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EXAMINER: Initial citation considered. Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.